

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

(Use as many sheets as necessary)



Sheet 1 of 1

Complete if Known

Application Number 10/014278

Filing Date December 11, 2001

First Named Inventor Hedin et al.

Group Art Unit 2877

Examiner Name Lee, Andrew

Attorney Docket No: 1010.8123U1

## US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate
ah	4,170,416	10/09/1979	Fencil			
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## FOREIGN PATENT DOCUMENTS

Examiner Initials *	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	T <sup>2</sup>

## OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	✓	Office Action dated March 10, Application Serial No. 10/014,277	

EXAMINER

DATE CONSIDERED 5/11/05



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# INFORMATION DISCLOSURE STATEMENT

PTO Form 1449

D c k t Numb r  
980.1123US01

**Serial Number**  
**10/014278**

**Appl ant(s)**  
**Hedin et al.,**

**Filing Date**  
12/11/01

**Gr up Art Unit**  
**2878**

**U.S. PATENT DOCUMENTS**

## FOREIGN PATENT DOCUMENTS

## OTHER DOCUMENTS

**Examiner:**

Date Considered: 5/16/05

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							YES	NO

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Examiner:

Date Considered:

5/19/05

**Group Art Unit  
2878**

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